

Extended availability of spare parts for 7200 Monitoring Systems

by Tom Pfob
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Excellent customer support is important to Bently Nevada. That is why we are pleased to announce that we can continue to supply spare parts for 7200 Monitoring Systems until June 1997.

We committed to supply spare parts for 7200 Monitoring Systems until June 1996, or until three years after we last shipped new 7200 Systems. We last shipped new 7200 Systems in June, 1993. Our policy was described in an article in the June 1991 issue of the *Orbit*.

We are pleased to announce that we can continue to provide spare parts for 7200 Systems until June 1997. Most of the components that we use in the manufacture of 7200 Systems are still available. However, because certain components are no longer available, we can no longer

manufacture certain spare parts. Contact your sales representative for information on 7200 spare parts availability.

We take excellent care of our customers at Bently Nevada by offering the highest level of support possible.

Many of our customers continue to receive value from their investment in 7200 Monitoring Systems. We will continue to offer them support. We thank all of our customers for choosing Bently Nevada products to protect and manage their machinery. ■

Dr. Agnes Muszynska receives 1996 Distinguished Research Award in Rotating Machinery



Prof. We-Jet Yang, President of the Pacific Center of Thermal-Fluid Engineering, presents the award to Agnes Muszynska.

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<http://www.bently.com>

Dr. Agnes Muszynska, Senior Research Scientist and Research Manager for Bently Rotor Dynamics Research Corporation, recently traveled to Honolulu, Hawaii to receive the 1996 Distinguished Research Award in Rotating Machinery. She was selected for this award by The Pacific Center of Thermal-Fluid Engineering because of her distinguished research achievements in the field of rotating machinery. The award citation, a plaque, and a check were given to Dr. Muszynska at the 6th International Symposium on Transport Phenomena and Dynamics of Rotating Machinery. ■